

Attorney Docket No. 040021-0306208
Client Reference: OPP 030890 US

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: GEON-OOK PARK

Application No.:

Confirmation

No:

Filed:

October 2, 2003

Group No.:

Examiner

For: FABRICATION METHOD OF SEMICONDUCTOR DEVICE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

APPLICATION DATA SHEET
37 C.F.R. § 1.76

BIBLIOGRAPHIC DATA

1. Applicant information

First applicant: GEON-OOK PARK
Citizenship: Republic of Korea
Residence: Seoul, Korea

2. Correspondence information

Correspondence for this application should be addressed as follows:

Customer No.: 00909

3. Application information

Title of Invention: FABRICATION METHOD OF SEMICONDUCTOR DEVICE

Docket number assigned to this application: 040021-0306208

Suggested Classification:

Class:

Subclass:

Technology Center to which subject matter is assigned:

Total number of drawing sheets: 4

Type of application:

Utility

Application is to be published. Suggested drawing figure for publication:

Secrecy order under § 5.2:

This application does not disclose subject matter of an application which is under a secrecy order pursuant to § 5.2.

4. Representative information

The following have a power of attorney or authorization of agent in this application:

Customer No.: 00909

5. Foreign priority information

Foreign priority is claimed for this application as follows:

Country: Korea
Application No.: 2002-0060306
Filing Date: October 2, 2002
Status: pending

6. Assignee information

The assignee(s) of this application is/are:


Anam Semiconductor Inc.
891-10, Daechi-dong, Kangnam-ku
Seoul, 135-523

Korea

Extent of interest of assignee in application: 100%

Date: October 2, 2003

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Signature of Practitioner
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